

Notice of References Cited	Application/Control No. 10/666,317	Applicant(s)/Patent Under Reexamination MUI ET AL.	
	Examiner Eric B. Chen	Art Unit 1765	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf et al., Silicon Processing for the VLSI Era, 1986, Lattice Press, Vol. 1, pp. 521, 523.
	V	Callister, Materials Science and Engineering, 1997, John Wiley & Sons, 4th ed., pp. 135-136.
	W	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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